Procedural Review Voting Sheet 2014 Cycle 1

1 REGION: Japan

2 COMMITTEE: Physical Interfaces & Carriers Committee

3 EVENT: Japan Spring Meetings 2014

4 DATE OF MEETING: 2014/4/18

5 PLACE OF MEETING: SEMI Japan, Tokyo

6 COMMITTEE CO-CHAIRS: Tsuyoshi Nagashima / Miraial, Tsutomu Okabe / TDK, Kenji Yamagata / Daifuku

7 SEMI STAFF: Chie Yanagisawa

A&R Voter: Name/Company Date: 200X/MM/DD

I. Document Number & Title

Document 5626	Document Title: LINE ITEM REVISIONS TO SEMI
	E154-0713, MECHANICAL INTERFACE
	SPECIFICATION FOR 450 mm LOAD PORT AND TO
	SEMI E166-0513, SPECIFICATION FOR 450 mm
	CLUSTER MODULE INTERFACE: MECHANICAL
	INTERFACE AND TRANSPORT STANDARD FOR
	ADDITION OF EFEM POCKET

II-1 Line item 1

Line Item 1	Line Item Title: New section 11 in the E154 for EFEM
	Lower Robot Volume, Add the related information in the
	E154 & E166

1. Tally (Staff to fill in)

Voting Tally: As-cast tally after the close of the voting period

A minimum of 60% of the voting interests that have voting members within the technical committee must return votes. (Regulations \P 9.6.1)

	Return		Distribution		Return Rate	
Yellow	44	÷	69	=	63.8%	>=60%
Lilac & Others	23					
Total Vote	67					
Reject	0					
Accept	28					

A&R	Not approved
Aak	Reason:

2. Rejects There was no reject vote received for Line Item 1 of the document 5626.

3. Comments Comment 1

	C	omm	ent 1							
	Referenced Section			*TF/Committee to fill in if necessary						
S		Fr	om	Alan Crocket (KLA-tencor)						
Comment		Com	ment	R1-5.1 (E154) change increase the wafer transfer plane to increase the height of the wafer transfer plane. It's not clear how the transfer plane is being increased as this is worded in the ballot. The corresponding text for E166 is clear that the height of the wafer transport plane is being increased.						
	[Discu	ission	The comment is relevant but it could be an editorial changes as below.						
		The	e commit	tee agreed to do one of the following actions.						
		*No	motion	is required in this step.						
			No furth	er action was taken by the committee.						
			Refer to	the task force for more consideration.						
			New Bus	siness						
			Other							
Action proposed	Editorial Change Refer to the description of E166 to ease understanding to E154.									
sode			Case 1: No vote in this section :							
sed			To be in	cluded and voted on in <u>4. Summary of Editorial Changes</u> .						
			Case 2:	Voted in this section :						
		X	Original "TO" fie	section number and at least one full sentence are required in "FROM" and elds.						
			FROM:	Section R1-2.1 of Related Information 1 of SEMI E154						
		1	SEMI Er and Tra	tion R1-2.1 of Related Information 1 of SEMI E154 166 —Specification for 450 mm Cluster Module Interface: Mechanical Interface nsport Standard						
			ation (If necessary)							

		2	In s to ti por atm mee volu rob To: In s to t por atm mee volu rob	OM: Section R1-5.1 of SEMI E154 some SME applications there is a requirement to increase the wafer transfer plane he processing side of the EFEM. This requirement in combination with the load t height specified in this document place design constraints on available nospheric robot options. For those SME applications where typical options do not et the design needs an EFEM Robot Lower Volume has been provided. This ume can be utilized to extend the available volume for a traditional atmospheric to operate. : Section R1-5.1 of SEMI E154 some SME applications there is a requirement to increase the wafer transfer plane the processing side of the EFEM. This requirement in combination with the load t height specified in this document place design constraints on available nospheric robot options. For those SME applications where typical options do not et the design needs an EFEM Robot Lower Volume has been provided. This ume can be utilized to extend the available volume for a traditional atmospheric the processing side of the EFEM. This requirement in combination with the load t height specified in this document place design constraints on available nospheric robot options. For those SME applications where typical options do not et the design needs an EFEM Robot Lower Volume has been provided. This ume can be utilized to extend the available volume for a traditional atmospheric ot to operate. <u>NOTE: Refer to the R1-3 of SEMI E166 for necessity of deferent nsport planes.</u>	
Justification (If necessary)				stification (If necessary)	
N	Motion b		oy/2n	d Shoji Komatsu (Acteon) / Mitsuhiro Matsuda (Hitachi Kokusai Electric)	
		Vot	е	11-0 Motion passed	
	۸ ۸	R		Not approved	
	A&R		Reason:		

4. Summary of Editorial Changes

There is no editorial change at this section.

5. Approval Conditions Check

APPROVAL CONDITION 1: All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations ¶ 9.6.2)

APPROVAL CONDITION 2: At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations \P 9.6.3)

Note: if both approval conditions are not satisfied, the balloted item fails.

		Accepts		(Accepts + Valid Rejects)			
Approval Rate	=	28	/	28	=	100.0%	>=90%

6. Preliminary action for this line item

-									
		This line item passed committee review as balloted.							
tion	X	Thi	This line item passed committee review with editorial changes						
Motion		This line item failed committee review and will be returned to the task force for rework.							
		Thi	s lin	e ite	m failed committee review and work will be discontinued.				
Μ	otion	by/ 2	nd by	,	Shoji Komatsu (Acteon) / Supika Mashiro (Tokyo Electron)				
	Disc	cussi	on	1	lone				
	I	Vote		1	11-0				
, ,	Fina	1 A of	ion	2	Motion passed				
	Final Action			Motion failed					
				Ap	proved				
	A&I	R		No	t approved				
		Reas			ion:				

II-2 Line item 2Line Item 2Line Item Title: Correction the z105 of table1 in E154

1. Initial Tally

	Return		Distribution		Return Rate	
Yellow	44	÷	69	=	63.8%	>=60%
Lilac & Others	23					
Total Vote	67					
Reject	0					
Accept	30					

2. Rejects

There was no reject vote received for Line Item 2 of document 5626.

3 Comments

There was no comment received for Line Item 2 of document 5626.

4. Summary of Editorial Changes

There is no editorial change at this section.

5. Approval Conditions Check

APPROVAL CONDITION 1: All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations ¶ 9.6.2)

APPROVAL CONDITION 2: At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations ¶ 9.6.3)

		Accepts		(Accepts + Valid Rejects)			
Approval Rate	=	30	/	Valid Rejects) 30	=	100.0%	 >=90%
			_				

Note: if both approval conditions are not satisfied, the balloted item fails.

6. Preliminary action for this line item

	X	Thi	This line item passed committee review as balloted.						
Motion		This line item passed committee review with editorial changes							
Mot		This line item failed committee review and will be returned to the task force for rework.							
		Thi	s lin	e iter	n failed committee review and work will be discontinued.				
М	otion	by/ 2	nd by	S	hoji Komatsu (Acteon) / Supika Mashiro (Tokyo Electron)				
	Disc	cussi	on	N	None				
	I	Vote		1	11-0				
Γ.	Fina	1 A of	ion	X	Motion passed				
	Final Action			Motion failed					
				Ap	proved				
	A&I	R			approved				
		Reas							

III. Safety Check

This section applies to the entire document. See Section 14 of the Regulations for further information

	X		This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.						
Motion:	This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete.								
Μ			Safety Chec (Regulations	klist is complete and has been included with the document throughout the balloting process. s \P 14.3)					
]	Moti	ion b	y/ 2nd by	Shoji Komatsu (Acteon) / Supika Mashiro (Tokyo Electron)					
	Ι	Discu	ission	None					
Vote 11-0 Motion passed									
	A 0_T		Not ap	proved					
1	A&R	x	Reason:						

IV. Intellectual Property Check

Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information

X		The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.							
			otentially m nown	GO TO SECTION V					
	X	know	ntially mate n but a Le material h	GO TO SECTION V					
		Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee							
	MOTION		Ask ISC for special permission to publish						
			Quit activity						
	N		Wait for LOA for patented technology or release of copyrighted items.						
	Motion by/2 nd by			Name (Company)/Name (Company)					
	Discussion			XXXX					
	Vote			XX-XX					
	-	Final Action			Motion Passed				
					Motion Failed				
•	&R	Not approved							
A		Reason:							

* Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

V. Action for this document

= o	X	Line item(s) 2 passed committee review as balloted and will be forwarded to the A&R procedural review.					
Motion (Check al applicabl items)	X	Line item(s) 1 passed committee review with editorial changes and will be forwarded to the A& for procedural review.					
app (Ch		Line item(s) [X], [X] and [X] failed committee review and will be returned to the task force for rework.					
		Line i	Line item(s) [X], [X] and [X] failed committee review and work will be discontinued.				
Motion by/ 2nd by			Shoji Komatsu (Acteon) / Supika Mashiro (Tokyo Electron)				
Discussion			None				
Vote			11-0				
Final A			X	Motion passed			
Final A	Actio	n		Motion failed			
		Appr	Approved				
A&R		Not a	t approved				
	Re	Reason:					